

Notice of References Cited	Application/Control No. 10/544,210	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner ADAM A. ARCIERO	Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	IPDL PAJ JPO machine translation for JP 2002-358963, Yamazaki et al. (December 13, 2002)
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